

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1577		SERIAL NO. 09/730,335	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Charles H. Dennison			
				FILING DATE December 4, 2000		GROUP 2811	

U.S. PATENT DOCUMENTS							
Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
ON	AA	5,923,999	07/13/99	Balasubramanyam et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS							
Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
ON	AJ	JP63012132	01/19/88	Japan (Sumi et al.)		Abstract	
ON	AK	JP63012152	01/19/88	Japan (Tsukamoto et al.)		Abstract	
ON	AL	JP8017758	01/19/96	Japan (Tawara)		Abstract & machine	

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AM			
AN			
AO			

EXAMINER <span style="float: right;">ON</span>	DATE CONSIDERED <span style="float: right;">2/9/04</span>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. MI22-1577		SERIAL NO. 09/730,335	
<div style="border: 1px solid black; border-radius: 50%; width: 100px; height: 100px; display: flex; align-items: center; justify-content: center; margin: 0 auto;"> <div style="text-align: center;">             1577 1 4 2000           </div> </div> <p><b>LIST OF ART CITED BY APPLICANT</b>          (Use several sheets if necessary)</p>				APPLICANT: Charles H. Dennison			
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Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
ON	AJ	JP8279553	10/22/96	Japan (Fujiwara)			Abstract & machine
ON	AK	JP10093077	04/10/98	Japan (Tsukamoto)			Abstract & machine
	AL						

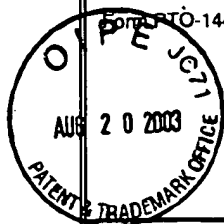
  

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
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Examiner's Initials	Class	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate	
ON	AA	5,696,017	12/9/97	Ueno				
ON	AB	6,357,909 B1	3/25/03	Lin, et al.				
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	AH							
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	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
ON	AM		J. Nulman, B. Cohen, and K. Ngan, "Titanium Silicide and Titanium Nitride Layers Formed in an integrated Multichamber System", Proc. VMIC Conference (1991), pp. 312-315.					
ON	AM		William C. O'Mara, Robert B. Herring, and Lee p. Hunt, "Handbook of Semiconductor Silicon Technology", Noyes Publ., Norwich, New York (1990), p. 684.					
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